



△				APPROVED	CHECKED	MATERIAL 材料		CHAMFER 一般面取		QUANTITY 個數				
△				T. A.	T. A.	TREATMENT 処理		FINISHING 仕上						
△						TREATMENT CONTACT 処理接点		DECENTRATION 偏芯						
△				DESIGNED	DRAWN	OVER 250 UP TO 1000	±0.3 ±0.5 ±1.0 ±0.2	ANGLE 角度	METHOD 図法	REMARK 適用 (機種名)				
△				T. A.	S. K.	OVER 63 UP TO 250	±0.2 ±0.3 ±0.6 ±0.15	UNIT (mm)		VS-TCH2-65C0				
△						OVER 16 UP TO 63	±0.1 ±0.2 ±0.4 ±0.1				SCALE	1 / 1	NAME	外觀圖
	DATE	EXCH NO.	REVISION 変更記事			OVER 0 UP TO 16	±0.05 ±0.1 ±0.2 ±0.1				TOLERANCES	A B C S	DATE	'09.04.03